

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re application of: **Youhei NAGAHAMA et al.**

Serial Number: **Not Yet Assigned**

Filed: **February 20, 2004**

**Customer No.: 38834**

For: **METHOD OF MANUFACTURING A SEMICONDUCTOR DEVICE USING A RIGID SUBSTRATE**

**INFORMATION DISCLOSURE STATEMENT**

Commissioner for Patents  
P. O. Box 1450  
Alexandria, VA 22313-1450

February 20, 2004

Sir:

In compliance with 37 CFR 1.56, Applicant(s) call(s) to the attention of the Patent and Trademark Office the references listed on the attached PTO-1449.

A copy of each of the references is enclosed herewith.

In the event there are any fees due in connection with the filing of this paper, please charge Deposit Account No. 50-2866.

Respectfully submitted,  
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Enclosures: PTO-1449; References (4)

<b>INFORMATION DISCLOSURE STATEMENT PTO-1449</b>	Attv. Docket No. <b>042120</b>	Serial No. New Appln.
	Applicant(s): <b>Youhei NAGAHAMA et al.</b>	
	Filing Date: <b>February 20, 2004</b>	Group Art Unit:

### U.S. PATENT DOCUMENTS

Examiner Initial	Document No.	Name	Date	Class	Subclass	Filing Date (If appropriate)
	AA					
	AB					
	AC					
	AD					

### FOREIGN PATENT DOCUMENTS

Document No.	Date	Country	Translation (Yes or No)
AE 2002-110718	04/12/02	Japan	Abstract & Discussed in the Spec.
AF 9-116050	05/02/97	Japan	Abstract
AG 2000-58716	02/25/00	Japan	Abstract
AH 2003-17625	01/17/03	Japan	Abstract
AI			

### OTHER DOCUMENTS

	AJ	
	AK	
Examiner	Date Considered	